- 1. Given the function  $f(x) = sinc^2(100x)$ , calculate the following:
  - a) Write an expression for the sampled version  $f_s(x)$  of this function with sample spacing equal to  $X_s$ .
  - b) Calculate  $F_s(\xi) = \mathcal{F}{f_s(x)}$ . What is the Nyquist frequency  $N_{\xi}$ ?
  - c) Plot  $F_s(\xi)$  in the range  $-300 \le \xi \le 300$  for the cases where the sampling frequency  $1/X_s = 2N_{\xi}, 1/X_s = 1.5N_{\xi}, \text{ and } 1/X_s = N_{\xi}.$
  - d) The function  $G(\xi)$  is used to recover the central spectrum of  $F_s(\xi)$ , where

$$G(\xi) = F_s(\xi)rect\left(\frac{\xi}{200}\right).$$

Write equivalent expressions for  $G(\xi)$  for the three sampling cases  $1/X_s = 2N_{\xi}$ ,  $1/X_s = 1.5N_{\xi}$ , and  $1/X_s = N_{\xi}$ . Note, this just means write a function that has the same shape as  $G(\xi)$  which will be *rect()* and *tri()* functions.

- e) Calculate and plot g(x) = F<sup>-1</sup>{G(ξ)} for the three sampling cases. How do these compare to the original function f(x)?
- 2. An interferometer is used to test the shape of an optical surface. The interference pattern in the camera sensor of the system is given by

$$I(x,y) = \frac{1}{2} + \frac{1}{2}\cos(2\pi r^4)$$

where  $r^2 = x^2 + y^2$ , and  $0 \le r \le 3mm$ . Do the following:

a) The interference pattern has a bright fringe whenever  $2\pi r^4 = 2m\pi$ , *m* integer. Two adjacent fringes occur when  $2\pi r_1^4 = 2m_o\pi$  and  $2\pi r_2^4 = 2(m_o - 1)\pi$ . Calculate the value of  $m_o$  when  $r_1 = 3mm$ .

- b) Calculate the value of  $r_2$  based on the results from part (a). What is the distance between these two fringes  $r_1 - r_2$ ? In this case, this will be the smallest period of the fringe pattern.
- c) What is the Nyquist frequency  $N_{\xi}$  in *cyc/mm* associated with the interference pattern?
- d) What sample spacing  $X_s$  is needed to avoid aliasing?
- e) Given this sample spacing, how many pixels *N* are required to cover the full width of the interference pattern?
- f) Are the values of N and  $X_s$  achievable with current camera sensor technologies?
- 3. Suppose the electric field at the plane z = 0 is given by

$$U(x, y, 0) = exp\left(i2\pi\left(\frac{\beta}{\lambda}\right)y\right) + exp\left(-i2\pi\left(\frac{\beta}{\lambda}\right)y\right).$$

Do the following:

- a) Calculate the angular spectrum  $A(\xi, \eta; 0)$  of this field.
- b) Given the transfer function  $H(\xi,\eta) = exp(i2\pi\sqrt{1/\lambda^2 \xi^2 \eta^2} \cdot z)$ , calculate the angular spectrum  $A(\xi,\eta;z)$  at a plane some distance z away.
- c) Calculate the field on this remote plane U(x, y, z).
- d) Plot the irradiance pattern  $|U(x, y, z)|^2$ . What is the separation between the peaks of the pattern?